



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

February 11, 2026

IGI Report Number

LG772683708

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

ROUND MODIFIED BRILLIANT

Measurements

6.05 - 6.07 X 4.14 MM

GRADING RESULTS

Carat Weight

1.03 CARAT

Color Grade

D

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

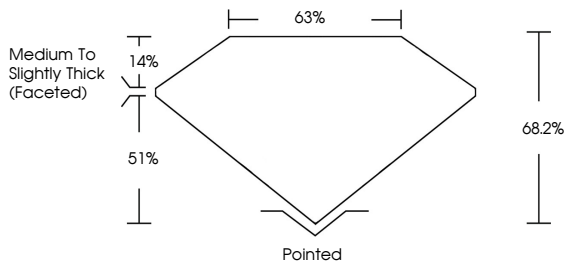
NONE

Inscription(s)

 LG772683708

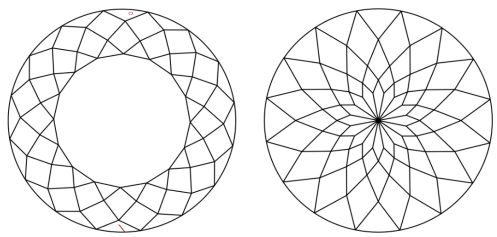
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.



Sample Image Used

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



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Color Grade

D

Carat Weight

1.03 CARAT

Clarity Grade

VS 1

Depth

68.2%

Graile

63%

Medium to Slightly Thick (Faceted)

Pointed

Culet

EXCELLENT

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

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